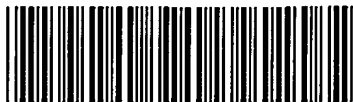


**Search Notes**

Application/Control No.

10/676,145

Examiner

Paul D. Kim

Applicant(s)/Patent under  
Reexamination

HA, TAE-HOE

Art Unit

3729

**SEARCHED**

Class	Subclass	Date	Examiner
29	603.03 729 737 757 759 760	11/1/2005	PK
360	98.07 98.08	↓	
	99.08		
	99.12		

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner
PGPub Text Search see attachment		11/1/2006	PK

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
Text Search EAST/NPL (IEEE)	11/1/2005	PK
Reviewed Relative Application 10/676,144	11/1/2005	PK
Updated Text Search EAST	4/20/2006	PK
Updated Text Search EAST/PGPub	11/1/2006	PK